

| Search Notes  | Application/Control No. | Applicant(s)/Patent under Reexamination |
|---|-------------------------|---|
| | 10/522,698 | KURIMURA ET AL. |
| | Examiner | Art Unit |
| | John D. Lee | 2874 |

SEARCHED

| INTERFERENCE SEARCHED | | | |
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| Class | Subclass | Date | Examiner |
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